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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets necessary)				COMPLETE IF KNOWN	
				Application Number	Unknown
				Filing Date	Hereith
				First Named Inventor	FUQUA
				Group Art Unit	Unknown 2644
				Examiner Name	Unknown P. Lee
SHEET	1	OF	1	Docket Number	AUDIOPH1100

JC879 U.S. PTO
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U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (If known)			
RL ↓		4,000,370		Smith et al	12/28/76	
		5,543,759		Comeau, II et al	08/06/96	
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		2001/00024751		Breed	05/31/01	
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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ³
RL		Hsieh et al, "The Future: MEMS Electret Microphones", Caltech Micromachining Lab., pp. 1-9	

Examiner Signature		Date Considered	9/16/05
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